



Docket No.: 60188-402

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

ODAKE, YOSHINORI, et al.

Application No.: 09/987,001

Filed: November 13, 2001

For: METHOD OF FABRICATING NONVOLATILE SEMICONDUCTOR MEMORY DEVICE

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

: Response Under 37 CFR 1.116 - Expedited Procedure
: Customer Number: 20277

: Confirmation Number: 6382

: Group Art Unit: 2812

: Examiner: Richard A. BOOTH

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	17	20	0	\$18.00 =	\$0.00
Independent Claims	1	3	0	\$88.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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WDC99 997454-1.060188.0402



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RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

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ODAKE, YOSHINORI, et al.	:	Confirmation Number: 6382
Application No.: 09/987,001	:	Group Art Unit: 2812
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AMENDMENT UNDER 37 C.F.R. 1.116

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P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated August 23, 2004, having a shortened statutory period for response set to expire on November 23, 2004, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.